



IFW

PATENT
81788.0265

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Yoshiyuki Tanaka, et al.

Serial No: 10/786,960

Confirmation No.: 4129

Filed: February 25, 2004

For: METHOD FOR CONTROLLING NON-
VOLATILE SEMICONDUCTOR
MEMORY SYSTEM

Art Unit: 2186

Examiner: Not assigned

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STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

The above-referenced application was filed on February 25, 2004 and the Notice of Publication of Application was received on January 19, 2005. To date, no further papers have been received in this case.

Please send the undersigned a Status Report on this application.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: September 27, 2005

By:

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